



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:) : Examiner: H. Nguyen
Kazunori IWAMOTO et al.) : Group Art Unit: 2851
Application No.: 09/866,600)
Filed: May 30, 2001	·)
For: STAGE APPARATUS WHICH SUPPORTS INTERFEROMETER, STAGE POSITION MEASUREMENT METHOD, PROJECTION EXPOSURE APPARATUS, PROJECTION EXPOSURE APPARATUS MAINTENANCE METHOD, SEMICONDUCTOR DEVICE MANUFACTURING METHOD, AND SEMICONDUCTOR MANUFACTURING FACTORY) June 16, 2005 :) :) :) :) :
U.S. Patent No. 6,867,849 B2) :
Issued: March 15, 2005)
Commissioner for Patents P.O. Box 1450	

Alexandria, VA 22313-1450

Attention: Certificate of Correction Branch

LETTER CALLING ATTENTION TO ERRORS IN PATENT

Sir:

Patentees note the following errors in the above-identified patent:

COLUMN 3:

Line 36, "inventor has" should read -- inventors have --.

COLUMN 11:

Line 65, "mark" should read -- bar --.

These errors are relatively insignificant. Therefore, Patentees believe that filing a Request for Certificate of Correction is not warranted. Rather, Patentees request that this paper

be placed of record in the official file of the subject patent.

Patentees believe no fee is due for filing this paper. Nevertheless, the Commissioner is

authorized to charge Deposit Account No. 06-1205 should any fee be deemed required.

Patentees' undersigned attorney may be reached in our Washington, D.C. Office by telephone at (202) 530-1010. All correspondence should continue to be directed to our belowlisted address.

Respectfully submitted,

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